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THE LIGHT ION PULSED POWER INDUCTION ACCELERATOR FOR ETF*

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Abstract

Our Engineering Test Facility (ETF) driver concept is based on HERMES III¹ and RHEPP² technologies. Actually, it is a scaled-down version of the LMF³ design incorporating repetition rate capabilities of up to 10 Hz CW. The preconceptual design presented here provides 200-TW peak power to the ETF target during 10 ns, equal to 2-MJ total ion beam energy. Linear inductive voltage addition driving a self-magnetically insulated transmission line (MITL) is utilized to generate the 36-MV peak voltage needed for lithium ion beams. The ~ 3-MA ion current is achieved by utilizing many accelerating modules in parallel. Since the current per module is relatively modest (~ 300 kA), two-stage or one-stage extraction diodes can be utilized for the generation of singly charged lithium ions. The accelerating modules are arranged symmetrically around the fusion chamber in order to provide uniform irradiation onto the ETF target. In addition, the modules are fired in a programmed sequence in order to generate the optimum power pulse shape onto the target. This design utilizes RHEPP accelerator modules as the principal power source.

Introduction

The Engineering Test Facility (ETF) has dual goals: first, to study moderate gain Inertial Confinement Fusion (ICF) targets with yields of the order of 30 to 100 MJ for nuclear weapon physics studies, and second, to provide the technical development necessary to demonstrate scientific and engineering feasibility for fusion energy production. In that aspect, ETF will address some requirements and goals of the Laboratory Microfusion Facility (LMF). Considered as a weapon simulator, ETF will provide much less output than LMF.

In order for ETF to be cost effective, the accelerator system must be able to drive several target chambers, a number of which will be strictly dedicated for U.S. defense applications and others which will test various Inertial Fusion Energy (IFE) reactor technologies.

We envision a kind of elevator system with multiple cabin-chambers for fast positioning and removal of the target chambers from the center area of the ion beam delivering system. An alternative scheme of beam switchyard would be very difficult to implement given the multiplicity of ion beams and the large beam currents.

The light-ion ETF pre-conceptual design is based upon the ion beam input requirements of the ~ 100-MJ yield ICF target. The driver design is modular and consists of 24 modules of two different types: A and B (Fig. 1). These modules are fired in a two-step sequence to provide the desired power pulse shape on the target (Fig. 2). The first pulse to arrive at the target, generated by the 12 A modules, has 20-TW flat top and 30-ns duration. The main pulse, delivered by the 12 B modules, arrives at the target 20 ns later. It has higher peak power (180 TW) but shorter duration (10 ns).

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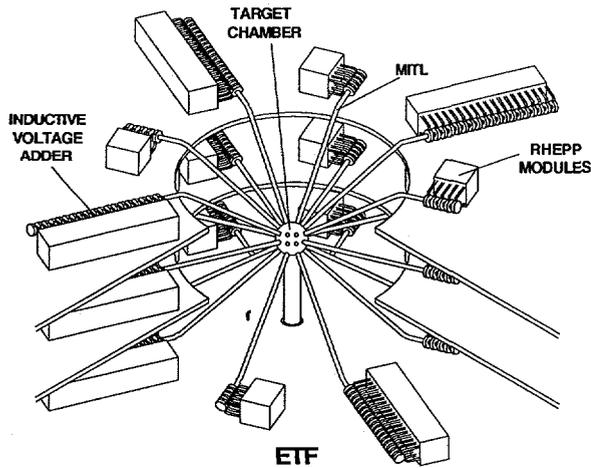


Figure 1. Cutaway view of the ETF Accelerator

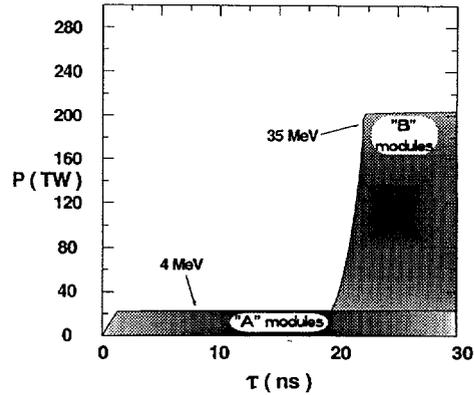


Figure 2. ETF target power requirements

The ETF Accelerator

The ETF pulsed power concept is based upon the successful Hermes-III and Repetitive High Energy Pulsed Power (RHEPP) technologies developed at Sandia during the last few years. The Hermes-III voltage adder³ generates a nominal 16-TW, 20-MV, 800-kA, 40-ns electrical pulse at a typical rate of about 5 shots per day. We propose that the required ETF repetition rate of several Hz could be obtained by replacing each pulse forming line (PFL) of Hermes III with the RHEPP technology being developed at SNL (Fig 3).² In the present Hermes III, each PFL supplies a 1-MV, 200-kA, 60-ns pulse to its respective inductive cavity (Hermes III has 20 cavities with 4 PFLs per cavity). This is done with a technology involving Marx generators, laser-triggered gas switching, and self-break water switching. In the new RHEPP technology, a motor driven alternator is the prime energy store, and metglas magnetic switches are used for pulse compression. The low energy RHEPP device has successfully operated at 120 Hz with 0.8-MV, 30-kA, 60-ns electrical pulses.² Thus, we believe that the basis exists for designing a 6 Hz ETF voltage adder via the combination of RHEPP and Hermes-III technologies.

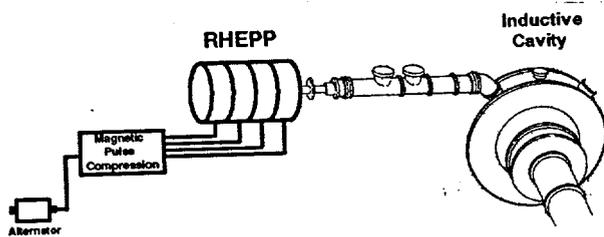


Figure 3. The ETF pulsed power concept

The selected number of modules, 24, is necessary to provide pulse uniformity on the target. Each module has its own diode producing the 24 separate ion beams focused on the ICF target. The beams propagate fully space charged and current neutralized in a 1 Torr helium atmosphere. The beams are bunched by a factor of 2 during transport to the target, driven by a ramped voltage pulse. The ion diodes can be single or double staged. the latter will require a triaxial voltage⁴ adder for each module. The power of the ions delivered to the diodes are shown in Fig. 2. The electrical power delivered by the voltage adders to the target is somewhat higher due to certain inefficiencies in the diode and in the transport system. We assume a 73% peak power efficiency from the diode to the target. Hence, the A modules deliver to the

diodes a total peak electrical power of 14 TW and the B modules of 123 TW. Table I summarizes the electrical output parameters for both types of modules.

Table I
Electrical Output Parameters per Module

	Module A	Module B
P (TW)	1.2	10.8
V (MV)	4	36
I (kA)	300	300
τ (ns)	60	20
W (MJ)	.74	.21

The A modules accelerate lighter than Li ions, He, and hence the required kinetic energy is lower and equal to 4 MV.

Accelerating Module Design

Each voltage adder of the 24 modules is connected to the corresponding diode via a long extension MITL which time-isolates the diode from the voltage adder. Thus the diode can operate at lower impedance than the voltage adder without affecting the voltage adder operation. Undermatching the diode load reduces the sheath electron current in the extension MITL and provides for more efficient pulse power coupling.

The ETF driver can be built with inductive cavities similar or identical to those of SABRE or HERMES III. The 12 low power modules A are one-half SABRE accelerators with only 5 out of the total ten cavities of the existing SABRE machine. Each of the five cavities are fed by one 1-MV RHEPP accelerator with a repetition rate that has been reduced to 6 Hz (the existing RHEPP device operates at 120 Hz).

The B modules have two stages. We analyzed two design options for the first and second stages: one that is composed of SABRE or HERMES-III cavities and 1-MV RHEPP accelerators and the other made up of 2.5-MV cavities and similar voltage RHEPP accelerators, one RHEPP accelerator per cavity. Thus, the B module can be built by 4.7 SABRE accelerators connected in series (47 cavities in total) or by nineteen 2.5-MV cavities.

Table II summarizes the design of both A and B modules. A third option is a combination of the previous two: it consists of 12 SABRE cavities for the first stage and fourteen 2.5-MV cavities for the second stage.

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Table II

ETF Module Design Summary

	MODULE A	MODULE B	
		FIRST STAGE	SECOND STAGE
Type of cavities	1-MV	1-MV or 2.5-MV	1-MV or 2.5
Number of cavities	5	12 or 5	35 or 14
RHEPP current (kA)	350	350	350
Number of RHEPP/cavity	1	1	1
Rep. rate (Hz)	6	6	6
Diode Current (kA)	286	294	294
Diode Voltage (MV)	4.2	9.6	27.3
Z _{DIODE} (Ω)	14.7	32.6	92.8

The design assumes a ~ 69% efficiency between the total power input into the voltage adders and the usable electrical output power delivered to the ion diodes. This efficiency estimate includes an additional 15% loss due to the positive polarity operation. The existing Hermes III routinely operates in the higher efficiency negative polarity mode and SABRE in the lower efficiency positive polarity mode.

Repetitive Pulsed Power for ETF

The RHEPP accelerator, although utilized in this application as a prime pulsed power source, is actually a linear induction voltage adder. The 1-MV model has 5 inductive cavities, each fed by a 200-kV pulse. The power pulse is produced by a cascade of magnetic switches which compress the 120-Hz CW pulses from a motor-driven alternator to a 60-ns final pulse width. The RHEPP voltage adder operates below the self-magnetic insulation limit and hence, utilizes oil to insulate the cathode electrode from the anode.

At present a RHEPP model with four cavities has successfully operated for 130,720 shots (~ 18 minutes). At that time all components had come to thermal equilibrium at or below design temperature limits. It produced 800-kV, 30-kA pulses with 84% efficiency. In the present ETF design, we assume a repetition rate of 6 Hz. Hence, the peak current could be increased by a factor of 20 without the need of additional cooling. However, to be conservative, we limit the current flowing through the RHEPPs to 350 kA, about half of the 600-kA maximum allowed at 6 Hz operation.

The 2.5-MV RHEPP model is also operational and provides similar pulse lengths and current output. The voltage adder is in vacuum and is self-magnetically insulated. Thus, the proposed repetitive pulsed power technology for ETF is presently available, and no large technological extrapolations were assumed in our conceptual design.

Beam Generation and ETF Transport

Our ETF intense light ion beam generation concept is based upon a combination of "single shot" ion diode technologies under development in the PBFA-II⁴ and SABRE⁵ facilities at SNL and the repetitive ion diode technologies being developed in conjunction with the RHEPP capability.⁶ At present, PBFA II is capable of generating an ~ 10 -TW, 10-MeV lithium ion beam in a single shot applied-B barrel diode. A high power applied-B extraction lithium ion diode is being developed on a single shot basis in the SABRE facility and in PBFA II (PBFA II-X). With RHEPP technology as a driver, repetitive ion diodes are currently being developed by Cornell and SNL at the ~ 0.1 -TW, 1-MeV (protons), 40-ns level. The first repetitive version of this diode has been operated in bursts at up to a 100 Hz repetition rate.⁶ A substantial development program could lead to a high power repetitive ion diode driven by a ETF module at the ~ 10 -TW, 30-MV, 40-ns per pulse level.

Self-pinch ion beam propagation is the most attractive concept for providing ion diode standoff from the ICF blast and radiation effects in an ETF application. In this scheme, each ion beam is ballistically focused down to a small radius (less than 1 cm), and then transported in the self-pinch mode at small radius for several meters to the target (Fig. 4). The target chamber fill gas parameters are chosen so that the beam is current neutralized to ~ 90 -98%. The net current forms an azimuthal field that confines the beam. IPROP simulations of self-pinch transport are encouraging.⁴ Self-pinch transport has not yet been demonstrated. Experiments to demonstrate self-pinch transport on the SABRE accelerator are being planned.

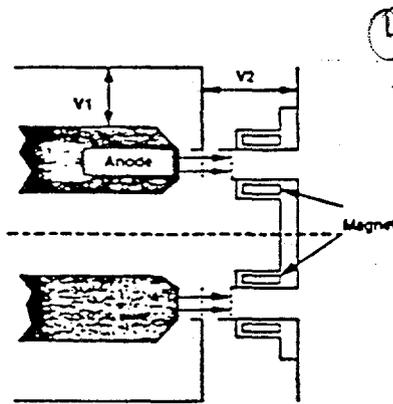


Figure 4. Self-pinch ion beam propagation

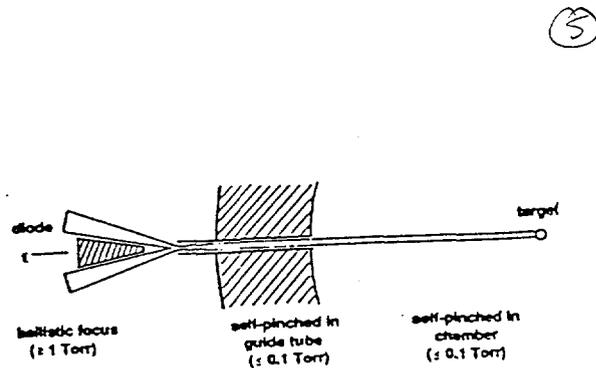


Figure 5. The two-stage extraction ion diode concept

The transport distance provides a means to use velocity ramping and beam bunching to obtain a factor of ~ 2 increase in beam intensity on target. Intrinsic to this concept is the need for an accurately programmed voltage pulse and a transport length of about 4 meters. Our approach to a low-divergence, programmed-voltage ion diode involves the two-stage diode technology under development at Sandia.⁸

A schematic of the geometry for the two-stage extraction ion diode is shown in Fig. 6. A single magnetic field region used to insulate against electron flow across the gap is divided into two accelerating regions by the addition of a mid-gap electrode. The beam is allowed to propagate to the second gap by making the mid-gap electrode from a mesh or a thin foil. The electrode allows beam transport between stages but isolates the accelerating electric fields, the beam magnetic field, and the diamagnetic effects of the gap electrons in the two gaps. In the first stage the ion current is limited only by the ion space charge and the effective anode-cathode gap. In the

second stage, the ion current is limited by the injected current from the first stage (assuming the electrode does not emit a

Conclusions

This ETF accelerator design is based on the robust HERMES-III and the proven RHEPP technologies. It has flexible modular configuration which offers risk control by an anticipated staged construction. Half of the 24 modules are identical to SABRE and the other half can be built with SABRE or similar 2.5-MV components. RHEPP accelerator units are utilized as prime power source replacing the conventional Marx generators and pulse forming lines. The pulsed power technology is currently available, and no large extrapolation from the present state of the art is required. Among the items that need substantial research and development are the repetitive, CW, ion source, and the transport and focusing of the ion beam onto the ICF target from a stand-off distance of ~ 4 m.

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